

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	3131	438/584.ccls. or 438/674.ccls. or 438/680.ccls. or 438/758.ccls. or 438/761.ccls. or 438/778.ccls.	USPAT	OR	ON	2007/02/13 17:24
L2	2113	1 not ("2007".ay. or "2006".ay. or "2005".ay. or "2004".ay. or "2003".ay. or "2002".ay.)	USPAT	OR	ON	2007/02/13 17:25
L3	1545	2 and (CVD or (chemical\$3 adj vapor adj deposit\$3))	USPAT	OR	ON	2007/02/13 17:25
L4	1068	3 and (plasma and (layer or (thin adj film)))	USPAT	OR	ON	2007/02/13 17:26
S1	1	("6613656").PN.	USPAT	OR	OFF	2007/02/13 16:42
S3	1	("20020004293").PN.	US-PGPUB	OR	OFF	2006/08/28 17:32
S4	1	("5902563").PN.	USPAT	OR	OFF	2006/08/28 17:33
S5	1	("4918031").PN.	USPAT	OR	OFF	2006/08/28 17:42
S6	1	("6756318").PN.	USPAT	OR	OFF	2006/08/28 18:16
S7	616	helical adj ribbon	USPAT	OR	ON	2006/08/28 18:18
S8	13	helical adj ribbon adj electrode	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/08/28 18:16
S10	13	S8 and plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/08/28 18:17
S11	15	S7 and semiconductor	USPAT	OR	ON	2006/08/28 18:24
S12	1431	plasma with (helical or helix)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/08/28 18:25
S13	844	S12 and (semiconductor or (thin adj film) or CVD or circuit)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/08/28 18:26

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S15	580	S13 and semiconductor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/08/28 18:26
S16	817	S13 not tissue	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/08/28 18:26
S17	601	S16 not ("2006".ay. or "2005".ay. or "2004".ay. or "2003".ay. or "2002".ay.)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/08/28 18:27
S19	125	S17 and (electrode with (helix or helical))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/08/28 18:44
S22	6	((("4999096") or ("5178739") or ("5431799") or ("5639357") or ("5961793") or ("6238528"))).PN.	USPAT	OR	OFF	2006/08/29 14:04
S23	3	((("4918031") or ("5902563") or ("6613656"))).PN.	USPAT	OR	OFF	2006/08/29 14:04
S24	223331	((chemical adj vapor adj deposit\$3) or CVD)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/12/14 10:44
S25	74553	S24 with plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/12/14 10:45
S26	12625	S25 and ((first and second) with (gas or vapor or gaseous))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/12/14 10:46

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S27	6497	S26 not ("2006".ay. or "2005".ay. or "2004".ay. or "2003".ay. or "2002".ay.)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/12/14 10:46
S28	1907	S27 and (plasma with (density or conformality))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/12/14 10:47
S29	19	S27 and (plasma with conformality)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/12/14 10:47
S30	2109	(CVD or (chemical\$2 adj vapor adj deposit\$3)) same ((first with (gas or gaseous or reactant)) and (second with (gas or gaseous or reactant)))	USPAT	OR	ON	2007/02/13 16:45
S31	3792	(CVD or (chemical\$2 adj vapor adj deposit\$3)) same ((first with (gas or gaseous or reactant)) and (second with (gas or gaseous or reactant)))	US-PGPUB; USPAT	OR	ON	2007/02/13 16:45
S32	2766	S31 and (((thin adj film) or layer) and plasma)	US-PGPUB; USPAT	OR	ON	2007/02/13 16:46
S33	1250	S32 not ("2007".ay. or "2006".ay. or "2005".ay. or "2004".ay. or "2003".ay. or "2002".ay.)	US-PGPUB; USPAT	OR	ON	2007/02/13 16:47